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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Gotkis et al.

Application No: 10/671,978

Filed: September 26, 2003

For: METHOD AND APPARATUS FOR WAFER
MECHANICAL STRESS MONITORING AND
WAFER THERMAL STRESS MONITORING

Attorney Docket No: LAM2P438

Examiner: DAVIS, O.

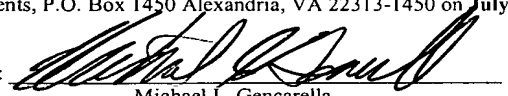
Group Art Unit: 2855

Date: July 14, 2005

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on July 14, 2005.

Signed:


Michael L. Gencarella

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE RATE FEE	ENTITY
TOTAL CLAIMS	13 -	24	00	X25 = \$	OR	X50 = \$	
INDEP CLAIMS	3 -	05	00	X100 = \$	OR	X200 = \$	
[] Multiple Dependent Claim Present and Fee Not Previously Paid				\$180		X360	\$
TOTAL				\$		\$	

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Applicant(s) hereby petition for a one-month extension of time to respond to the outstanding Office Action.
Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No.).

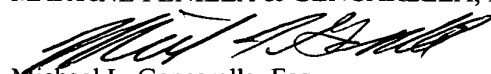
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Enclosed is our Check No. in the amount of \$ to cover the additional claim fee and/or extension of time fees.

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If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P438).
A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE PENILLA & GENCARELLA, LLP


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Signed:

Michael L. Gencarella

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir:

Applicants submit this amendment in response to the Office action dated April 14, 2005. Please enter the following amendments and remarks in the above identified application:

Amendments to the claims are reflected in the listing of claims, which begins on page 2 of this paper.

Replacement drawing sheets are included at the end of the amendment

Remarks/Arguments begin on page 7 of this paper.